| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|----------|---------|--|--|---------------------|---------|------------------|
| Ll | 69813 | capacitor near3 (form or forming or formation or fabrication) | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | OR | ON | 2005/02/01 16:53 |
| L2 | 2148965 | threshold voltage or Vt or "V.sub.t" | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | OR | ON | 2005/02/01 16:59 |
| L3 | 257298 | 12 near4 (shift or change or changing or altering of affect or effect or affecting) | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | OR | ON | 2005/02/01 16:59 |
| L4 | 12230 | 11 and 13 | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | OR | ON | 2005/02/01 16:57 |
| L5 | 8478441 | high k or high dielectric constant or high kappa or tantalum oxide or "Ta.sub.2 O. sub.5 " | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | OR | ON | 2005/02/01 17:00 |
| L6 | 135120 | threshold voltage or Vt or "V.sub.t" | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | ADJ | ON | 2005/02/01 16:59 |
| L7 | 17279 | l6 near4 (shift or change or changing or altering of affect or effect or affecting) | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | OR | ON | 2005/02/01 16:59 |
| L8 | 1156 | 11 and 17 | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | OR | ON | 2005/02/01 16:59 |
| L9 | 40266 | high k or high dielectric constant or high kappa or tantalum oxide or "Ta.sub.2 O. sub.5 " | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | ADJ | ON | 2005/02/01 17:00 |
| L10 | 156 | 18 and 19 | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | ADJ | ON | 2005/02/01 17:00 |

| L11 | 78 | barrier layer near6 l6 | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | ADJ | ON | 2005/02/01 17:00 |
|-----|----|------------------------|--|-----|----|------------------|
| L12 | 3 | 110 and 111 | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | ADJ | ON | 2005/02/01 17:00 |





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